Docket No. 274380US0PCT

MAIL 10540873 - GAU: 4172

MAIL TOP PCT PCT

JC10 Rec'd PCT/PTO 15 JUL 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Noriya IZU, et al.

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10/540,873

GAU:

FILED:

June 27, 2005

EXAMINER:

FOR:

PROCESS FOR PRODUCING OXYGEN PARTIAL PRESSURE DETECTING PART OF RESISTANCE

OXYGEN SENSOR

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- □ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number <u>15-0030</u>. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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EFS-Web Receipt date: 07/15/2005

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SHEET 1 OF

Form PTO 1449 U.S. DEPARTMENT OF COMMERCE			ATTY DOCKET NO.		SERIAL NO.					
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LIST OF	REFE	RENCES CITED BY API	PLICANT	Noriya IZU, et al.						
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				U.S. PATENT DOCUMENTS						
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		DOCUMENT NUMBER	DATE	COUNTRY		TRANSLATION YES NO				
	AO	56-058652	05/21/1981	JP(with English abstract)				NO		
	AP	55-137334	10/27/80	JP(with English abstract)				NO		
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conformance and not considered. Include copy of this form with next communication to applicant.										



U.S. PCT Application Serial No.: 10/540,873 Docket No.: 274380US0PCT

STATEMENT OF RELEVANCY

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3) References <u>AP</u> references is being s		_ are discussed in the with.	specification. A c	opy of these
4) Reference		prior art known to A	pplicant. A copy o	of these